

Notice of References Cited	Application/Control No. 10/691,574	Applicant(s)/Patent Under Reexamination HAYASHI ET AL.	
	Examiner John Rivell	Art Unit 3753	Page 1 of 1

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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